

PATENT ASSIGNMENT

Electronic Version v1.1
 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT						
NATURE OF CONVEYANCE:	ASSIGNMENT						
CONVEYING PARTY DATA							
<table border="1"> <thead> <tr> <th>Name</th> <th>Execution Date</th> </tr> </thead> <tbody> <tr> <td>Keita KATO</td> <td>08/24/2012</td> </tr> <tr> <td>Atsushi NAKAMURA</td> <td>08/24/2012</td> </tr> </tbody> </table>		Name	Execution Date	Keita KATO	08/24/2012	Atsushi NAKAMURA	08/24/2012
Name	Execution Date						
Keita KATO	08/24/2012						
Atsushi NAKAMURA	08/24/2012						
RECEIVING PARTY DATA							
Name:	FUJIFILM CORPORATION						
Street Address:	26-30, Nishiazabu 2-chome						
City:	Minato-ku, Tokyo						
State/Country:	JAPAN						
Postal Code:	106-8620						
PROPERTY NUMBERS Total: 1							
<table border="1"> <thead> <tr> <th>Property Type</th> <th>Number</th> </tr> </thead> <tbody> <tr> <td>Application Number:</td> <td>13598087</td> </tr> </tbody> </table>		Property Type	Number	Application Number:	13598087		
Property Type	Number						
Application Number:	13598087						
CORRESPONDENCE DATA							
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Total Attachments: 2 source=ASSIGNMENT#page1.tif source=ASSIGNMENT#page2.tif							

OP \$40.00 13598087

ASSIGNMENT

12F00480
(12S0178-1)

In consideration of value received, I, having a mailing address at c/o FUJIFILM Corporation, 4000 Kawashiri, Yoshidacho, Haibara-gun, Shizuoka-ken, Japan, and a residence as stated below next to my name, the sole inventor (if only one name is listed below) or a joint inventor (if plural inventors are listed below) of an invention described in an application for United States patent entitled:

METHOD OF FORMING PATTERN, ACTINIC-RAY- OR
RADIATION-SENSITIVE RESIN COMPOSITION AND ACTINIC-RAY- OR
RADIATION-SENSITIVE FILM

said application having been filed on
and assigned Application No. ;
sell and assign to
FUJIFILM Corporation
a corporation of Japan, having a business address at
26-30, Nishiazabu 2-chome, Minato-ku, Tokyo 106-8620 Japan

its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right, title and interest in and to said invention as disclosed, shown and described in said application for United States patent : (check one)

- executed concurrently herewith;
- executed separately herefrom;

and in and to all applications for patent and patents for said invention including all divisions, reissues, continuations, substitutions and extensions thereof and all rights arising under or pursuant to any and all international agreements, treaties or laws relating to the protection of industrial property, including rights of priority, resulting from the filing of any of said applications; and I authorize and request any official whose duty is to issue patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I agree that on request and without further consideration, but at the expense of said Assignee, I will communicate to said Assignee or its representatives all facts known to me respecting said invention and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuing, reissue or other applications, make all rightful oaths and declarations, and generally do everything possible to aid said Assignee to obtain and enforce proper patent protection for said invention in all countries.

I hereby grant the following law firm the power to insert on this Assignment any further identification which may be necessary or desirable in order to comply with the Rules of the U.S. Patent and Trademark Office for recordation of this document.

Sughrue Mion, PLLC, 2100 Pennsylvania Avenue, N.W. Washington, D.C.
20037-3213

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12F00480
(12S0178-1)

<u>Inventor: (Signature)</u>	<u>Date</u>	<u>Residence</u>
<u>Keita Kato</u> Keita Kato	<u>2012. 8. 24</u>	<u>Shizuoka, Japan</u>
<u>Atsushi Nakamura</u> Atsushi Nakamura	<u>2012. 8. 24</u>	<u>Shizuoka, Japan</u>